## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Vishwanathan et al.

Application No.: 09/608,537

Filed: 6/30/2000

Title: POLISHING PADS FOR CHEMICAL

MECHANICAL PLANARIZATION

Attorney Docket No.: 126.

Commissioner for Patents Alexandria, VA 22313-1450 Group Art Unit:

3724

CENTRAL FAX CENTER Examiner:

T. Eley

AUG 2 0 2004

## **AMENDMENT**

Dear Sir:

In response to the action dated June 7, 2004, kindly disregard the amended claims mailed August 17, 2004 and amend the specification as follows: